



OK TO ENTER: /MM/ (06/15/2009)

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PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No.: 10/594,480 Group Art Unit: 1793

Filing Date: September 28, 2006 Examiner: Michael Marcheschi

Applicant: Yoshiharu OHTA, et al.

Title: SEMICONDUCTOR POLISHING COMPOSITION

Attorney Docket: 2691-000052/US

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May 21, 2009

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AMENDMENT UNDER 37 CFR §1.116

Sir:

In response to the Office Action mailed February 25, 2009, the following amendments and remarks are respectfully submitted in connection with the above-identified application.

Amendments to the Claims begin on page 2 of this Amendment.

Remarks begin on page 4 of this Amendment.

	Claims remaining after Amendment		Highest number previously paid for		Present extra
Total	4	-	20	=	0
Independent	1	-	3	=	0